



PATENT
Docket No.: Q106-US1

1734

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED
JUL 24 2003
GROUP 1700

In re Application of: :
Hisashi Tsukamoto et al. :
Application No.: 10/031,022 : Group Art Unit: 1734
Filing Date: January 14, 2002 : Examiner: N/A
Title: LITHIUM THIN FILM :
LAMINATION TECHNOLOGY :
ON ELECTRODE TO INCREASE :
BATTERY CAPACITY :

CERTIFICATE OF MAILING VIA
CERTIFIED FIRST CLASS MAIL (37 CFR 1.8)

Dated July 16, 2003


P.O. Box 1450
Commissioner for Patents
Alexandria, VA 22313-1450

I hereby certify that the following attached documents are being deposited with the United States Postal Service as first class certified mail under 37 CFR 1.8 on the date indicated above and are addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313.

1. Transmittal Letter for Information Disclosure Statement (in duplicate)
2. PTO Form 1449 with copies of cited references
3. Self addressed stamped return postcard

July 16, 2003
Date of Deposit

Lisa K. Robbins
Name of Person Mailing paper or fee


Signature